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AMENDMENTS TO THE CLAIMS

- 1-27 (Canceled)
- 28. (New) An array of semiconductor packages, comprising:

a substrate having upper and lower surfaces, one of said upper and lower surfaces including a first plurality of grooves dividing said substrate into a plurality of segments;

a plurality semiconductor dies, each semiconductor die being substantially aligned with a segment; and

an encapsulant over said plurality of semiconductor dies, said encapsulant having a second plurality of grooves.

- 29. (New) The array of semiconductor packages of claim 28, wherein said second plurality of grooves is substantially aligned with said first plurality of grooves.
- 30. (New) The array of semiconductor packages of claim 28, wherein said first plurality of grooves are formed on said upper surface of said substrate.
- 31. (New) The array of semiconductor packages of claim 30, wherein said plurality of semiconductor dies are formed on said lower surface of said substrate.
- 32. (New) The array of semiconductor packages of claim 28, wherein said first plurality of grooves are formed on said lower surface of said substrate.
- 33. (New) The array of semiconductor packages of claim 32, wherein said plurality of semiconductor dies are formed on said upper surface of said

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substrate.

34. (New) The array of semiconductor packages of claim 28, wherein each of said plurality of semiconductor dies is electrically connected to a respective segment of said substrate.

35. (New) A method of forming an array of semiconductor packages, said method comprising:

dividing a substrate into a plurality of segments by forming a first plurality of grooves on said substrate;

forming an array of semiconductor dies over said plurality of segments, each semiconductor die formed to be substantially aligned with a segment; and

forming an encapsulant having a second plurality of grooves over said array of semiconductor dies.

- 36. (New) The method according to claim 35, wherein said step of forming an encapsulant having a second plurality of grooves is performed such that said second plurality of grooves are substantially aligned with said first plurality of grooves.
- 37. (New) The method according to claim 35, wherein said step of forming an encapsulant having a second plurality of grooves comprises:

providing an upper member over said array of semiconductor dies, said upper member surrounding, and forming a cavity around, each semiconductor die;

providing a resin in said cavity; and

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removing said upper member.

38. (New) The method according to claim 35, wherein said first plurality of grooves is formed on an upper surface of said substrate.